

PATENT
99-CT-371/DP2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Michele VULPIO

: Group Art Unit: 1734

Serial No.: 10/693,639

Filed: October 24, 2003

: Confirmation No.: 8902

For: METHOD OF USING SACVD
DEPOSITION AND CORRESPONDING
DEPOSITION REACTORINFORMATION DISCLOSURE STATEMENTCommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The attached Form PTO-1449 provides a listing of information which may be relevant to the subject application. This IDS is not intended as a representation that better art is not available, nor that other art than that identified exists; nor that the information provided is prior art; nor that a search has been made.

This IDS is submitted under:

- ☒ 37 CFR 1.97(b) - No Fee.
☐ 37 CFR 1.97(c) - No Fee, with Certification.
☐ 37 CFR 1.97(c) - Fee.
☐ 37 CFR 1.97(d) - Fee and Certification.

The Commissioner is authorized to charge any required fees under 37 CFR 1.17(p) and (i)(1) to Deposit Account No. 50-1556.

Respectfully submitted,

Date:

7/29/04

By:

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I hereby certify that this correspondence is being deposited with the United States Postal Service by first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Kathleen Schlosdon
Name of Person Mailing PaperKathleen Schlosdon
Signature of Person Mailing Paper7/29/04
Date of Deposit

AUG 03 2004

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OFFICE-313

Form PTO-1449	U.S. Dept. of Commerce Patent & Trademark Office	Atty. Docket No. 99-CT-371/DP2	Serial No. 10/693,639			
List of Documents Cited by Applicant <small>(Use several sheets if necessary)</small>		Applicant: Michele VULPIO				
		Filing Date: October 24, 2003	Group: 1734			
U.S. PATENT DOCUMENTS						
Ex'r's In'l	Document Number	Date	Name	Class	Sub-class	Filing Date, if applicable
	AA1	5,356,477	October 18, 1994	Visser.		
	AA2	5,324,690	June 28, 1994	Gelatos et al.		
FOREIGN PATENT DOCUMENTS						
	Document Number	Date	Country	Class	Sub-class	Trans'n Yes/No
	AA3	0 299 249	January 18, 1989	Europe		Yes
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
	AA4	Raupp, G. B. et al. "Conformality of SiO ₂ / sub 2/films from tetraethoxysilane-sourced remote microwave plasma-enhanced chemical vapor deposition", Journal of Vacuum Science and Technology (Vacuum, Surfaces and Films), May-June 1995 pp. 676-680, XP002143946.				
	AA5	European Search Report for European Patent Application No. 00830153.3. dated July 31, 2001.				
Examiner:			Date Considered:			
<small>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>						